

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/052,097	KIM ET AL.	
Examiner	Art Unit	
Clemence Han	2616	

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Class	Subclass	Date	Examiner			
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INT	INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner			
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
see Search History Printout	11/20/2006	СН
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